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| Application Number | 10/525,763 |
| Filing Date | August 25, 2005 |
| First Named Inventor | Janusz Murakowski |
| Art Unit | 1756 |
| Examiner Name | Christopher G. Young |
| Attorney Docket No. | UOD-211US |

SHEET 2 of 2

NON-PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published | T ² |
|-----------------------|--------------------------|--|--------------------------|
| | 4 | CHENG, CHUAN C. et al., "New Fabrication Techniques for High Quality Photonic Crystals," J. Vac. Sci. Technology B., 15(6), November/December 1997, pp. 2764-2767 | <input type="checkbox"/> |
| | 5 | SCHNEIDER, GARRETT J. et al., "Combination Lithography for Photonic-Crystal Circuits," J. Vac. Sci. Technology B., 22(1), January/February 2004, pp. 146-151 | <input type="checkbox"/> |
| | 6 | MURAKOWSKI, JANUSZ et al., "Combination Lithography for Photonic Crystal Circuits," Proceedings of SPIE, 5000, July 2003, pp 1-8 | <input type="checkbox"/> |
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